Notice of Allowability	Application No.	Applicant(s)
	10/774,406	TANABE ET AL.
	Examiner	Art Unit
	Thanhha Pham	2813
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. This communication is responsive to <u>06/01/04</u> .		
2. The allowed claim(s) is/are <u>1-6</u> .		
3. The drawings filed on 10 February 2004 are accepted by the Examiner.		
 4.		
 DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 		
Attachment(s) 1. ⊠ Notice of References Cited (PTO-892)	5. ☐ Notice of Informal P	atent Application (PTO-152)
Notice of Praftperson's Patent Drawing Review (PTO-948)	6. 🔲 Interview Summary	(PTO-413),
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 2/10/04,6/1/04	Paper No./Mail Dai 08), 7. 🔀 Examiner's Amendr	
4. Examiner's Comment Regarding Requirement for Deposit	8. Examiner's Statement	ent of Reasons for Allowance
of-Biological Material		whend
	CARL WHITEHI SUPERVISORY PATEI TECHNOLOGY CE	NT EXAMINEF.

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows to correct informalities according to MPEP 1302.04(J).

In claim 1,

line 12, change "a first" to - the first -

Allowable Subject Matter

- 1. Claims 1-6 are allowed.
- 2. The following is an examiner's statement of reasons for allowance: Recorded Prior Art fails to disclose or suggest the combination of the process steps for fabricating a semiconductor integrated circuit device as recited in the base claim 1 including: replacing gas ambient, in the heat treatment chamber where the wafer gas been introduced, with nitrogen gas; preparing moisture at a first temperature from oxygen and hydrogen gas by use of a catalyst; transferring the thus-prepared moisture into the heat treatment chamber to form a wet oxidation atmosphere over a first major surface of the wafer inside the heat treatment chamber while keeping the moisture in a gaseous state; performing thermal oxidation treatment of a silicon member over the first major surface of the wafer to form an insulating film in the wet oxidation atmosphere in the heat

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treatment chamber by heating the first major surface of the wafer up to a second temperature higher than the first temperature.

- 3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thanhha Pham whose telephone number is (571) 272-1696. The examiner can normally be reached on Monday and Thursday 9:00AM 9:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).